

THE INVENTION CLAIMED IS:

1. An apparatus adapted to scrub a substrate,  
comprising:

5 a plurality of rollers adapted to rotationally  
support a substrate in a substantially vertical orientation;  
and

at least one brush member positioned to contact an  
edge bevel of the substrate with a stationary surface of the  
10 brush member at a location between two of the rollers.

2. An apparatus adapted to scrub a substrate,  
comprising:

a plurality of rollers adapted to rotationally  
15 support a substrate in a substantially vertical orientation;  
a finger having a first end extending away from the  
substrate, a second end extending toward the substrate, and a  
central portion between the first end and the second end, the  
finger being pivotally mounted at the central portion; and

20 a brush member mounted on the second end of the  
finger and in contact with an edge bevel of the substrate.